

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :  
Chul-Hwan Choi et al. : Box New Applications  
Serial No. (new) : Attorney Docket No. SEC.890  
Filed January 18, 2002 :

SELF-CONTAINED SEMICONDUCTOR DEVICE MANUFACTURING  
EQUIPMENT HAVING COMPACT ARRANGEMENT OF LOAD-LOCK AND  
PROCESSING CHAMBERS

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**PRELIMINARY AMENDMENT**

Honorable Commissioner For Patents  
Washington, D.C. 20231

Sir:

Prior to the examination of the above-identified application, the following  
amendments and remarks are submitted:

In the Specification<sup>1</sup>

***Kindly rewrite the paragraph at page 10, lines 9-11, to read as follows:***

FIG. 14 is a top view of a still further embodiment of semiconductor device  
manufacturing equipment having a robot that includes a branched wafer support  
according to the present invention.

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<sup>1</sup> A marked-up copy of any revised paragraphs of the original  
specification is attached as ATTACHMENT "A".

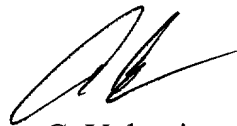
**REMARKS**

By this Preliminary Amendment, minor changes have been made to the specification.

Entry of this Preliminary Amendment is respectfully requested.

Respectfully submitted,

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Dated: January 18, 2002

## ATTACHMENT “A”

### Additions/Deletions to the Specification:

*Page 10, lines 9-11:*

FIG. 14 is a top [~~longitudinal-sectional~~] view of a still further embodiment of semiconductor device manufacturing equipment having a robot that includes a branched wafer support according to the present invention.